



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/602,395
Filing Date June 22, 2000
Inventor John T. Moore
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Pham, T.
Attorney's Docket No. MI22-1384
Title: Methods of Forming Oxide Regions Over Semiconductor Substrates

#13
Crawford
Hoff
J. Mancilla
8/20/02

Assistant Commissioner for Patents
Washington, D.C. 20231
Attention: Official Draftsman

Correction is OK
to entered
TSP
10/28/02

LETTER SUBMITTING FORMAL DRAWINGS

Please enter the enclosed formal drawing sheet 3 in the above-referenced application in place of the originally filed drawing 3. The formal sheet is being submitted to voluntarily amend Fig. 6 to correctly label a feature of the drawing.

The proposed change is indicated in red on an attached copy. Fig. 6 has been amended to appropriately label a feature of the drawing by replacing the incorrect label "52" with the appropriate label "46". The formal drawing incorporates the proposed change.

Acknowledgment of receipt of the formal drawing sheet 3 and its acceptance into the file is requested.

Respectfully submitted,

Date: August 6, 2002

By: Jennifer J. Taylor
Jennifer J. Taylor, Ph.D.
Reg. No.: 48,711
WELLS ST. JOHN P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828
(509) 624-4276

Enclosures: Substitute formal drawing sheet 3/4; red-inked copy of formal drawing sheet 3/4